Inventor: Craig M. Carpenter; Ross S. Dando; Philip H. Campbell;

Allen P. Mardian; Jeff N. Fuss; Randy W. Mercil

Title: Chemical Vapor Deposition Apparatuses and Deposition

Methods

Assignee: Micron Technology, Inc.

Attorney Docket No. MI22-1559

INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

REMARKS

The citations listed, copies attached, may be material to the examination of the subject application and are therefore submitted in compliance with the duty of disclosure defined in 37 CFR §1.56. The Examiner is requested to make these citations of official record in this application. No admission is made regarding whether all the submitted references are prior art.

The materials cited are presented to assist in and expedite examination of this application. The present invention is considered to be patentable over the cited materials. Expeditious examination and allowance of this application as a patent are therefore urged in order that the public may benefit from the disclosure and commercialization of the invention.

EL465855526

Respectfully submitted,

Dated: 8 March 2001	Inventor: Craig M. Carpenter
/ /	Craig´ M. Carpenter
Dated: <u>3/8/0(</u>	Inventor:
	Ross S. Dando
Dated: Morch, 8, 01	Inventor:
<i>-</i> ,	Philip H. Campbell
Dated: 3-8-01	Inventor: Mer Washing
	Allen P. Mardian
Dated: $3-8-0/$	Inventor: Jeff N Fuss
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Dated: $\frac{\delta 3}{\delta k} \delta \sqrt{\delta 7}$	Inventor:
	Randy W. Mercil
Dated: 15 Mar 2001	Attorney:
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Form PTO-1449		U.S. DE PATENT	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1559			SERIAL NO. O		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Craig M. Carpenter et al			387		
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				U.S. PATENT DOCUMENT						
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